

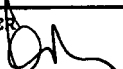
PTO-1449 REPRODUCED INFORMATION DISCLOSURE CITATION IN AN APPLICATION September 19, 2003 (Use several sheets if necessary)	ATTORNEY DOCKET NO. 2251.2002-009	APPLICATION NO.	
	APPLICANT Tzvi Avnery		
	FILING DATE	CONFIRMATION NO.	GROUP

U.S. PATENT DOCUMENTS				
EXAM- INER INI- TIAL	REF. NO.	DOCUMENT NUMBER	ISSUE DATE / PUBLICATION DATE	NAME
6	AA	3,869,362	03/04/1975	Machi et al.
	AB	4,324,759	04/13/1982	Aoki et al.
	AC	4,882,020	11/21/1989	Maezawa et al.
	AD	4,915,916	04/10/1990	Ito et al.
	AE	4,969,984	11/13/1990	Kawamura et al.
	AF	5,015,443	05/14/1991	Ito et al.
	AG	5,041,271	08/20/1991	Aoki et al.
	AH	5,319,211	06/07/1994	Matthews et al.
	AI	5,357,291	10/18/1994	Schonberg et al.
	AJ	5,378,898	01/03/1995	Schonberg et al.
	AK	5,457,269	10/10/1995	Schonberg
	AA2	5,468,356	11/21/1995	Uhm
	AB2	5,523,577	06/04/1996	Schonberg et al.
	AC2	5,539,212	07/23/1996	Matthews et al.
	AD2	5,582,807	12/10/1996	Liao et al.
	AE2	5,693,195	12/02/1997	Saito et al.
	AF2	5,700,311	12/23/1997	Spencer
	AG2	5,744,811	04/28/1998	Schonberg et al.
	AH2	5,770,785	06/23/1998	Tamura et al.
	AI2	5,834,722	11/10/1998	Tokunaga et al.
	AJ2	5,853,680	12/29/1998	Iijima et al.
	AK2	5,993,612	11/30/1999	Rostaing et al.
	AA3	6,077,488	06/20/2000	Jain et al.
	AB3	6,080,281	06/27/2000	Attia
7	AC3	4,752,450	06/21/1988	Dietrich et al.

EXAMINER <i>6 May</i>	DATE CONSIDERED <i>6/21/07</i>
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U.S. PATENT DOCUMENTS				
EXAM- INER INI- TIAL	REF. NO.	DOCUMENT NUMBER	ISSUE DATE / PUBLICATION DATE	NAME
b	AD3	3,761,065	09/25/1973	Rich et al.
d	AE3	4,167,466	09/11/1979	Orr, Jr. et al.

EXAMINER 	DATE CONSIDERED 6/21/07
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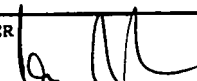
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	APPLICANT Tzvi Avnery		
	FILING DATE	CONFIRMATION NO.	GROUP

FOREIGN PATENT DOCUMENTS					
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO
6	AL	GB 2 173 779 A	22/10/1986	United Kingdom	
↓	AM	63302924	09/12/1988	Japan (Abstract Only)	
	AN	EP 0 579 105 A1	19/01/1994	EPO	
↓	AO	WO 97/01386	16/01/1997	PCT	
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	APPLICANT Tzvi Avnery		
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)		
6	AR	Tian, C., and Vidal, C.R., "Single to Quadruple Ionization of CO ₂ Due to Electron Impact," <i>Phys. Rev. A</i> , 58(5): 3783-3795 (1998).
6	AS	Darici, Y., <i>et al.</i> , "Electron Beam Dissociation of CO and CO ₂ on ZnS Thin Films," <i>J. Vac. Sci. Technol. A</i> , 17(3), 692-697 (1999).
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